



ELECTRONIC COPY

LG779633560
Report verification at igi.org



February 28, 2026
IGI Report Number **LG779633560**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **EMERALD CUT**
Measurements **12.24 X 7.51 X 5.31 MM**
GRADING RESULTS
Carat Weight **5.04 CARATS**
Color Grade **D**
Clarity Grade **VVS 2**

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GRADING RESULTS

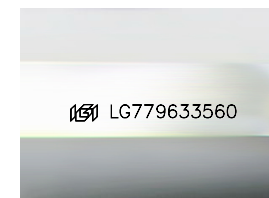
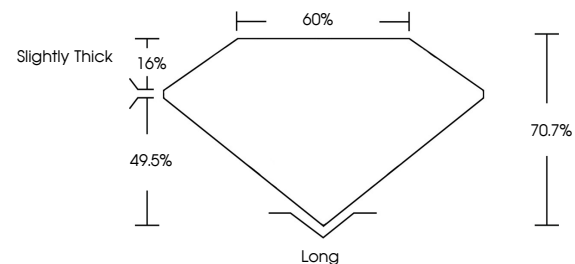
Carat Weight **5.04 CARATS**
Color Grade **D**
Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG779633560**

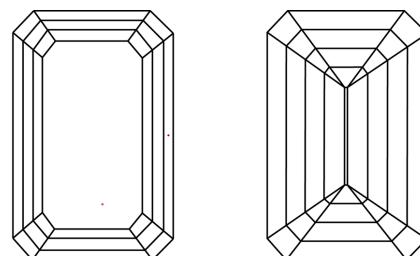
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

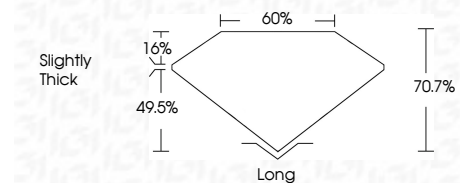
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI



February 28, 2026
IGI Report No LG779633560
EMERALD CUT
12.24 X 7.51 X 5.31 MM
5.04 CARATS
Color Grade **D**
Clarity Grade **VVS 2**
Table **70.7%**
Girdle **60%**
Slightly Thick
Culet **Long**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG779633560**
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